

Docket No. 005332/DISPLAY/AKT/BG

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Assistant Commissioner for Patents

Washington, D.C. 20231

Re: Inventor(s):

Sheng Sun

Title:

Photo-Assisted Chemical Cleaning and Laser Ablation Cleaning of Process Chamber

Transmitted herewith is the patent application identified above, including:

- X Specification, claims and abstract, totaling <u>42</u> pages.
- X Drawings totaling 2 pages, \_\_ Formal X Informal.
- X Executed Declaration and Power of Attorney.
- $X = \sqrt{\text{Assignment of the invention to } Applied Materials, Inc.}$
- X Assignment Recordation Cover Sheet
- \_\_ Information Disclosure Statement, PTO Form 1449 and ( ) References

FEE CALCOUNT		BARINATA TA			
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	- 68	- 20 =	-48	X \$18	\$864
Independent Claims	-11	- 3 =	- 8	X \$80	\$640
Basic Filing Fee \$710					\$710
TOTAL FEES					\$2,214

- XX The Commissioner is hereby authorized to charge \$2,214 to Deposit Account No. 50-1074
- XX The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- XX Please address all future correspondence to:

PATENT COUNSEL

APPLIED MATERIALS, INC.

**Legal Affairs Department** 

**P.O.BOX 450A** 

Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to. Box Patent Application, Assistant Commissioner for Patents, Washington, D C 20231

Date of Deposit 5-29-0/

Robert W. Mulcahy

Registration No. 25,436

Respectfully submitted,